

**Dr. Lee, Eung-Sug**, Tenured Principal Researcher, Director of Nano-Convergence Industrial Promotion Center, Korea Institute of Machinery and Materials

Dr. Lee, Eung-Sug has made a significant contribution for the development of nanotechnology in both research and policy fields. He has made remarkable research in nanoimprint lithography technology through University-Institute-Industry collaboration. Moreover he played a leading role in establishing networks of nano researchers and vitalizing nano communities.

#### Academic experience

Korea Advanced Institute of Science and Technology, Ph. D. (1990-1997)

Seoul National University, Mechanical Engineering, M.S. (1980-1982)

Seoul National University, Mechanical Engineering, B.S. (1976-1980)

#### Job Experience

Tenured Principal Researcher, Korea Institute of Machinery and Materials (1983-Present)

Director of Nano-Convergence Industrial Promotion Center (2012- present)

Director, Division of Nano & Convergence Technology, National Research Foundation of Korea (2009-2011)

Cross-appointed professor, KAIST, Mechanical Engineering (2010-Present)

Professor, University of Science and Technology, Nano-Mechatronics (2004-2009)

Cross-appointed professor, Chungnam National University (2002-2004)

Post Doc. University of California, Berkeley (1998-1999)

President, Korean Society of Precision Engineering (2013)

Member, The National Academy of Engineering of Korea (2011-Present ) \*\*

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